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Versatile pressure and temperature controlled cell for neutron reflectometry and small-angle neutron scattering

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Abstract. We have designed and realized a temperature and pressure controlled cell for Neutron Reflectometry (NR) and Small Angle Neutron Scattering (SANS) that is compatible with simultaneous optical transmission and resistivity measurements. The cell can accommodate samples up to 102 mm (4 inch) in diameter, can be pressurized from vacuum up to 10 bar gas pressure and the sample temperature can be controlled up to 350°C. The four single crystal quartz windows ensure both a good neutron and optical transmission and hence can be used in combination with in-situ optical transmission measurements. We present the cell and illustrate its performance with a series of neutron reflectometry experiments performed on Ta based thin films under a hydrogen containing atmosphere.

Keywords: Pressure and temperature controlled cell, neutron reflectometry, small angle neutron scattering, sample environment

The presence of certain gases and temperature have a substantial impact on the material properties, including solar cells, steels, polymers and hydrogen sensing materials. In these fields of research, *in situ* neutron scattering experiment are of inestimable value to asses the influence of these external parameters on the material properties [4,13–16,20,26,27]. In addition, experiments often need to be performed in inert atmospheres to prevent possible oxidation or nitration. For example, Neutron Reflectometry (NR) is used to quantify the amount of hydrogen absorbed by hydrogen storage [9,12,17,18,21,23,24] and optical hydrogen sensing materials as a function of the applied hydrogen pressure and temperature [2,3,5,7,11]. In the latter case, NR provides valuable insights in the relationship between the structural properties such as the hydrogen concentration and layer expansion and its optical performance as a hydrogen sensor. Furthermore, Small Angle Neutron Scattering (SANS) is frequently used to study the structure of precipitates in steels as well as hydrogen inclusions, both of which are drastically affected by temperature and gas environment. To allow such in situ/operando neutron studies [28], it is vital to develop reliable, compact and versatile sample environments in which both temperature and gas pressure/environment can be controlled simultaneously.

Here, the aim is to design, construct and validate a versatile pressure and temperature controlled cell for NR and SANS studies. Specifically, the design requirements are that we can control the pressure between $P=10^{-6}$ and 10 bar (absolute pressure), can be used in combination with hydrogen gas and allows temperature control between 25° and 350°C. The cell should be compatible with NR and SANS measurements, allowing the transport of beams of rectangular ($40 \times 2 \text{ mm}^2$) and circular sections (Ø18 mm). In addition, it should be compatible with samples of up to 101.2 mm (4 inch) in diameter and 10 mm in thickness for neutron reflectometry measurements. Furthermore, the cell should be compact (not exceeding $300 \times 300 \times 300 \text{ mm}^3$ in volume) such that it can be easily mounted on the beamline and have a gas volume of less than 1 liter) for safety reasons and to reduce gas consumption and allow swift changes in pressure. Furthermore, all materials that are potentially illuminated by neutrons should not

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activate. Moreover, the windows trough which the neutron beam is transported should be optically transparent to allow simultaneous optical transmission measurements while also having a high transmission for neutrons as well as generating a low background during measurements.

In this work, we developed a versatile pressure and temperature controlled cell for neutron reflectometry and small-angle neutron scattering studies. Specifically, the temperature in the cell can be controlled up to 350°C and the pressure up to 10 bar. We first describe the cell and then illustrate its performance with a series of neutron reflectometry experiments. The cell and engineering drawings thereof are available to the user community upon reasonable request.

1. Design and construction

1.1. Design

Figures 1 and 2 display schematics, an exploded view and photograph of the cell. It consists of 3 main components: (i) the body of the cell including a circular lid, (ii) an insert that serves as a sample support and heating plate and (iii) a base plate with 4 cylindrical posts to mount the body of the cell to the support plate. With the exception of the heating plate (stainless steel), all components are made from aluminum. All materials and suppliers are specified in Table 1. The dimensions of the base plate are $220 \times 220 \text{ mm}^2$.

The cell can be used in two modes: positioned horizontally for NR measurements (Fig. 1a) and positioned vertically for SANS measurements (Fig. 1b). In the NR configuration, the sample is inserted by removing the lid from the top. For the SANS configuration, the cell is rotated by 90° with respect to the NR configuration. This implies that the sample is loaded from the side and that the cell is supported by 4 cylindrical posts from the side at which the rectangular NR window is mounted. The cylindrical windows (see details below in the next section) of the cell that accommodate the transport of the SANS beam allows the transport of a circular beam with a maximum diameter of 18 mm². As the maximum scattering angle for this beam size is $\theta_{\text{max}} = 4^{\circ}$ (Fig. 2), the largest *Q*-value that can be probed in combination with $\lambda = 1.0$ nm neutrons is $Q_{\text{max}} = \frac{4\pi}{\lambda} \sin \theta_{\text{max}}/2 = 0.4 \text{ nm}^{-1}$. This *Q*-range is even larger when the wavelength is decreased and/or when a smaller beam size is used.

1.1.1. Windows

The cell has four single crystal quartz windows (VM-TIM GmbH, Jena, Germany) to allow the passage of neutron beams with minimum loss of intensity. Two of these windows, each $80 \times 40 \times 10 \text{ mm}^3$, allow the passage

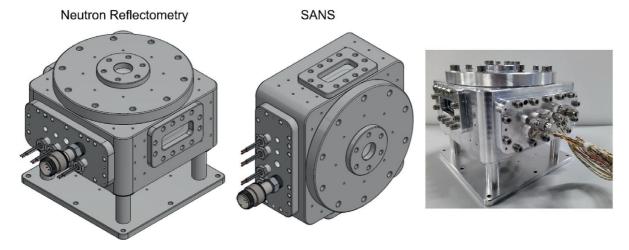


Fig. 1. Schematics of the cell in (a) NR and (b) SANS modes. (c) Photograph of the cell in horizontal orientation ('NR mode').

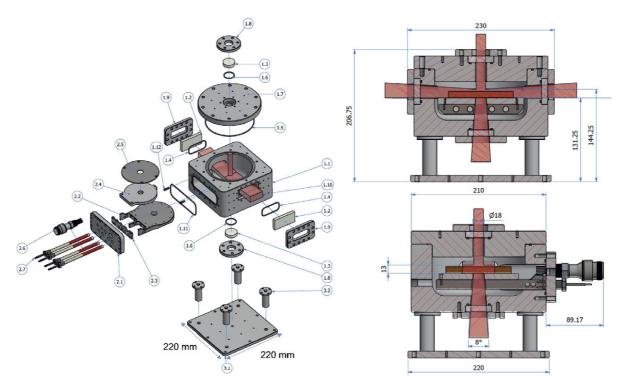


Fig. 2. (left) Exploded view of the pressure and temperature controlled cell. (right) Schematics of the cell in NR and SANS mode in which the beam is illustrated. The cell consists of three main components: (1) the cell body including the lid, the (2) insert and the base plate (3.1) with cylindrical posts (3.2). Unless stated otherwise, the components are made from aluminum. The cell body consists of (1.1) main body, (1.2) quartz windows for reflectometry, (1.3) quartz windows for SANS, (1.4) Kalrez O-Ring 55.25 × 2.62 mm², (1.5) Kalrez O-Ring 158.42 × 2.62 mm², (1.6) Kalrez O-Ring 29.82 × 2.62 mm², (1.7) lid, (1.8) aluminum plate to clamp the quartz windows for SANS (1.9) and reflectometry (1.10), (1.11) Kalrez O-Ring 29.82 × 2.62 mm², (1.12) parallel pin (dowel pin). (2.1) Back plate for the insert, (2.2) stainless steel heating plate, (2.3) stainless steel holder plate, (2.4) sample support plate, (2.5) clamp for SANS samples, (2.6) multipin connector, (2.7) heating rods. The drawing is to scale and the red shading illustrates the neutron beams when the cell is used for reflectometry and SANS (1.10). The dimensions are indicated in mm.

of a beam with maximum dimensions of $60 \times 30 \text{ mm}^2$ and are used for NR experiments. The other two windows are used for SANS measurements and are cylindrical with a diameter of 40 mm and a thickness of 10 mm, allowing the passage of a circular beam with a maximum dimension of 18 mm. The windows are optically transparent and polished on both sides with s/d = 40/20 and L/10 per 50 mm. The optical axis is normal to the polished surface and the windows thus facilitate simultaneous optical transmission measurements.

The windows are mounted with the help of two aluminum clamps that are fixed to the cell body with M6 bolts. To seal the windows, Kalrez O-rings are used with a diameter of 2.62 mm and placed in a groove.

The neutron transmission of the quartz windows was measured at room temperature ($T=22^{\circ}\text{C}\pm1^{\circ}\text{C}$) on the ROG time-of-flight neutron reflectometer of the Reactor Institute Delft. Both incident slits and the slit in front of the ³He detector were set to a height of 2 mm and a width of 40 mm and the double-disc chopper was operated at a frequency of 17.7 Hz and a distance of 280 mm between the discs. The resulting transmission displayed in Fig. 3 is high. It increases from 0.87 at $\lambda=0.15$ nm to its maximum value of 0.95 at $\lambda=0.3$ nm. Subsequently, it decreases to 0.89 at $\lambda=1.1$ nm. These results are qualitatively similar to earlier transmission measurements of single crystal quartz [19].

1.1.2. Insert for sample support and heating

Figure 4 displays a detailed view of the insert which is made of an aluminum back plate to which a stainless steel 310(S) heating plate is assembled. Stainless steel 310(S) was selected for its excellent corrosion resistance

Table 1

This table reports the material specifications and suppliers of all used items

Item	Material	Supplier
Cell body	Aluminium 6082	Salomon's Metalen B.V., Groningen, The Netherlands
Back plate sample support	Aluminium 7075	Salomon's Metalen B.V., Groningen, The Netherlands
Heating plate	Stainless Steel 310(S)	Salomon's Metalen B.V., Groningen, The Netherlands
Heating rods $(4\times)$	Custom made 60 V, 38 W heating rods with a diameter of 0.371 inch (9.4 mm) and total length of 7.1 inch (180 mm). One features a Type K Thermocouple	Kurval B.V., Nieuw Vennep, The Netherlands
O-rings	Kalrez FFKM 75 6375	DuPont, Wilmington, Delaware, United States
NR window	$80 \times 40 \times 10 \text{ mm}^3$ single crystal quartz, both $80 \times 40 \text{ mm}^2$ sides polished with s/d 40/20, L/10 and optical axis normal to the polished surface	VM-TIM GmbH, Jena, Germany
SANS window	d = 40 mm, t = 10 mm single crystal quartz	VM-TIM GmbH, Jena, Germany
Multipin connector	1/2 inch NPT 10 pin Multipin Connector MIL-C 5015, 10094-11-A	MPF Products Inc., Gray Court, South Carolina, United States
Bolts for windows		Fabory B.V, Tilburg, The Netherlands
Bolts for the lid $(10\times)$		Fabory B.V, Tilburg, The Netherlands
Parallel pin (dowel pin)	Parallel pin (dowel pin) hardened, m6 DIN 6325 Steel	Fabory B.V, Tilburg, The Netherlands

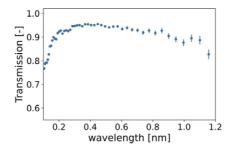


Fig. 3. Wavelength-dependent neutron transmission of the pressure cell in NR mode.

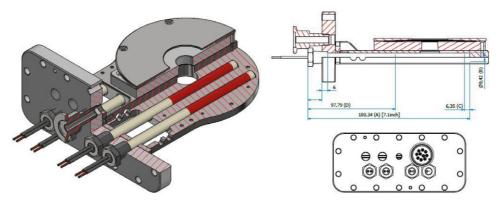


Fig. 4. Schematics of the insert that supports and heats the sample. The insert is made of an aluminum back plate, through which the 4 heating cartridges are inserted with a 1/4 inch NPT connection. A 1/2 inch NPT multipin connector is used to facilitate electrical connections and one 1/4 inch NPT connection can be used to directly connect a vacuum hose to the cell. Two additional 1/8 inch NPT are placed that can be used for other connections. The heating rods are positioned inside a stainless steel plate on top of which a sample support plate is mounted. A circular hole with a diameter of 18 mm facilitates the transmission of the neutron beam for SANS measurements and optical measurements.

as well as high strength at high temperatures. On top of the heating plate, a sample support plate is positioned to which samples with a maximum diameter of 4 inch (101.6 mm) can be clamped. To allow optical transmission and SANS measurements, a 18 mm diameter hole is made in the heating and sample support plate.

The contact area between the back plate and the heating plate is minimized to reduce the heat flow to the cell body. In the cell no heat shields are used because the temperature stays relatively low and there is limited space. Some heat is still transmitted to the body, either via conduction and radiation and also via convection if the cell is not operated under vacuum. The body can be water cooled with a cooling block to prevent it becoming too hot for material and personal safety. This block is made in house from a brass bar with a channel drilled in it and is attached to the side of the body.

Four cartridge heaters are placed inside the heater plate. The heaters (Watlow 2285-7052) are 60 V, 200 W each and have a K-type thermocouple to monitor the internal temperature. The cartridges have a diameter of 0.371 inch (9.4 mm) and a total length of 7.1 inch (180 mm) of which only the section in the heater plate is heated. The cold zones are 3.85 inch (98 mm) on the connection side and 0.25 inch (6.4 mm) on the tip side. The cartridge heaters feature a maximum temperature of 760°C and have a 1/4 inch NPT plug (stainless steel 304) that allow them to be fixed to the back plate. The heating rods are connected in series such that the heating will stop if one of the heaters malfunctions. The electrical connections are placed outside the cell to prevent electrical discharges at low gas pressures. To improve the thermal connection each heater is fixed along its length with three screws in the bottom of the heater plate. This is especially important when operating in vacuum where there is no convection.

A 1/2 inch NPT 10 multipin connector with a maximum design pressure of 34 bar is placed to allow for electrical connections for e.g. resistivity measurements and the placement of additional thermocouples. The connector allows for a maximum of 10 A and 700 V to be transported and has for example been used for four-point resistivity measurements.

1.2. Stress simulations

Stress simulations were performed to assess the structural integrity of the cell when it is pressurized to 10 bar. These simulations were performed with ANSYS R21.1 Academic using the finite element method. The mechanical stress analysis is performed on the individual components of the cell. This is a worst case scenario as in this way there is no support from other parts. The calculations are done at a pressure of 2 MPa, i.e. a factor two higher than the maximum design pressure of 1 MPa. All relevant material parameters used for the computations can be found in Table 2.

Table 3 reports the results. Comparing the yield strength of the various materials with the maximum Von Mises Stress computed for all parts it can be seen that the stresses are well below what is mechanically desired. Indeed, the highest stresses are observed on the cell body itself with a maximum calculated Von Mises stress of 84 MPa,

Aluminum	Stoinlage stool	Quartz wir
Material parameters used f	for the stress and then	mal simulations
	Table 2	

	Aluminum 6061	Stainless steel heating plate	Quartz window and sample	Helium (10 bar)	Argon (10 bar)
Density [kg/m ³]	2,700	7,750	2,650	0.163	1.620
Thermal conductivity [W/(m.K)]	167	2	1	0.152	0.016
Specific heat [J/(kg.K)]	896	480	710	5,193	520
Thermal expansion coefficient [10 ⁻⁵ /K]	2.36	1.70	1.30		
Young's modulus [MPa]	68,900	193,000	7,254		
Bulk modulus [MPa]	25,903	169,300	3,664		
Shear modulus [MPa]	67,549	73,664	3,100		
Poisson's ratio	0.33	0.31	0.17		
Compressive yield strength [MPa]	276	207	77		
Tensile yield strength [MPa]	276	207	1,100		

Part Material Yield strength Safety Maximum calculated material [MPa] Von Mises Stress [MPa] factor Cell body Aluminum 6082 260 84 3 Lid Aluminum 6082 260 39 7 Aluminum 7075 503 Back plate sample support and heating plate 61 8 Quartz window for NR Quartz 77 12 6 Window clamp for NR Aluminum 6082 260 69 4 77 Quartz window for SANS Quartz 13 6 Window clamp for SANS Aluminum 6082 260 54 5

Table 3

Results of the stress simulations at which the cell is pressurized to a pressure of 2 MPa

being a factor three lower than the yield strength of the material. Furthermore, we observe that the maximum deformation of the windows is 0.05 mm, of the cell body 0.04 mm and of the lid 0.03 mm.

1.3. Thermal simulations

Steady-state thermal simulations were performed to (i) estimate the required heating power (heating loss to the environment), (ii) assess the temperature homogeneity of the sample and (iii) evaluate the temperature of the maximum temperature of the outer cell wall. Similar to the stress simulations, these simulations were performed with ANSYS R21.1 Academic. All relevant material parameters can be found in Table 2. During the simulations an ambient temperature of 22°C was assumed and the sample was modeled as a quartz disc with a diameter of 4 inch (101.6 mm) and a thickness of 10 mm. The simulations were performed both by positioning the cell in NR (horizontal) and SANS mode (vertical).

The simulations were performed for both vacuum and a gas atmosphere of 10 bar of argon and 10 bar of helium. In the simulations the heating cartridges were heated to 400° C. The combination of these parameters, i.e. the highest pressure and temperature, represent the most extreme designed operating conditions of the cell. To estimate the heat loss to the environment, we consider the convection Q_{con} heat transfer. The latter we calculate using:

$$Q_{\rm con} = hA(T - T_{\rm amb}) \tag{1}$$

with A the surface area, T the mean temperature of the outside of the cell and $T_{\rm amb}$ the ambient temperature, for which we take $T_{\rm amb} = 22$ °C. h is the heat transfer coefficient between aluminum and air for which we take $h = 10 \text{ W.m}^2/\text{K}$.

Figures 5–7 and Table 4 report the results of the simulations showing three important points. First of all, the results indicate that the power of the heating rods is sufficient to heat the sample to T = 350°C. In all cases the heat loss to the environment is smaller than the heating power of the heating rods (800 W). The large difference in heat loss between vacuum and argon (10 bar) on the one hand and helium on the other hand is caused by the orders of magnitude higher thermal conductivity of helium (Table 2).

Secondly, the results show that the temperature of the outer wall and the windows remains modest, at max. 65°C in a 10 bar helium atmosphere. In the case of vacuum and argon at 10 bar, the outer wall and window temperature are much lower and below 40°C. Thirdly, we observe that the thermal gradients within the samples remain modest. At the maximum temperature, we observe that the gradient is for NR measurements at max. 3°C over the surface of a 4 inch wafer, whilst for SANS it is only 1°C.

As we will see later, the thermal simulations represent an ideal case. In particular, it does not take into account the non-ideal contact between various materials, such as the heating plate and the sample support plate, the sample support plate to the sample, as well as the limited heat transfer between the heating rods and the heating plate. These effects are especially relevant when operating under vacuum. As a result, to reach a certain sample temperature, the heating rods and support plate have to be at a higher temperature than expected based on the simulations. The sample still reaches the desired maximum temperature.

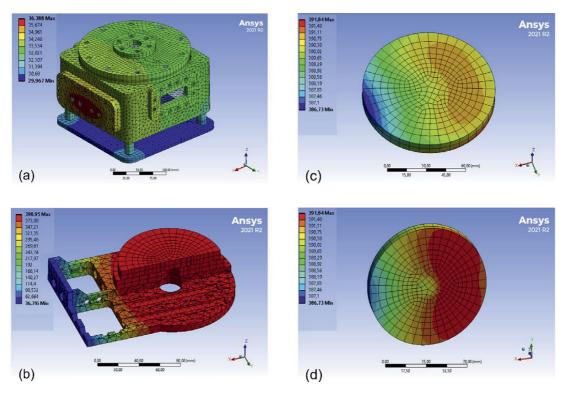


Fig. 5. Temperature distribution of the cell when the temperature of the heating rods is set to 400° C and the cell is under vacuum. (a) Entire cell body, (b) sample support and heating plate, (c) close-up of the sample in NR mode, (d) close-up of the sample in SANS mode. The black lines indicate the elements used for the finite element method simulations.

1.4. Pressure and flow control

The pressure control of the cell is schematically depicted in Fig. 8 and all components are specified in Table 5. For the purposes of our measurements, the cell is operated as a vacuum flow cell. Pressure is supplied by a gas cylinder and substantially reduced to 11 bar with a double-stage pressure regulator. A MKS instruments pressure controller reads the pressure from the MKS instruments Baratron manometer and controls a solenoidal inlet valve (n.c.) to regulate the pressure inside the cell. A vacuum pump is connected to the other side of the cell. In between the vacuum pump and the cell, a mass flow controller (n.c.) and a solenoidal outlet valve, powered by a Delta Elektronica, are placed. The function of the solenoidal outlet valve is threefold: (i) to be able to swiftly reduce the pressure, (ii) provide maximum pumping capacity when operating in vacuum, and (iii) to increase the flow at low pressures ($P \lesssim 50$ mbar) where the mass flow controller alone provides insufficient flow. In addition, an air valve is located next to the flow controller to allow the cell to be vented. The pressure on the pump is monitored with a Thyracont vacuum transducer, providing an indication of the quality of the vacuum and/or the flow.

The pressure and flow can be set, read and logged using a bespoke LabVIEW program. To facilitate this, the MKS controller and outlet valve are connected to a personal computer (pc) through a National Instruments USB DAQ. The mass flow controller and vacuum transducer are connected directly to the pc using a USB and RS485 connection, respectively.

The cell was vacuum leak tested using a helium leak tester Alcatel ASM-180TD+. The leak rate was found to be lower than 10^{-5} mbar.l/s. This implies that the vacuum level is limited by the pump and not by the cell itself.

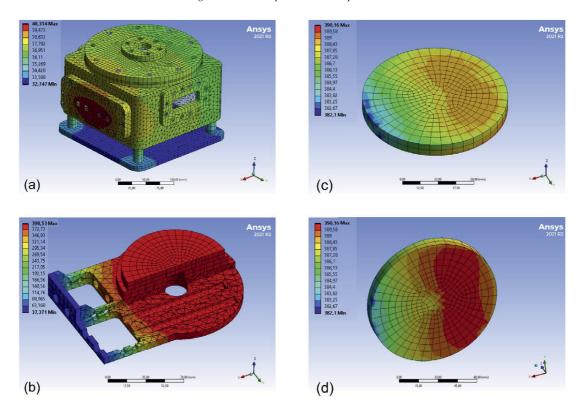


Fig. 6. Temperature distribution of the cell when the temperature of the heating rods is set to 400°C and the cell is pressurized with 10 bar of argon. (a) Entire cell body, (b) sample support and heating plate, (c) close-up of the sample in NR mode, (d) close-up of the sample in SANS mode. The black lines indicate the elements used for the finite element method simulations.

1.5. Temperature control

The temperature of the cell is controlled using a Genlab Bench Top Control Station BTC2000/485 (Genlab Ltd., Cheshire, United Kingdom). It uses two Eurotherm P116/CC/VH/LRX/R/4CL controllers, each connected to one K-type thermocouple in the cell. One Eurotherm controller regulates the temperature of the sample support plate from the thermocouple placed in it. The temperature control station works by switching a solid state relay on and off using pulse-width and pulse-frequency modulation at up to 5 Hz with the help of PID control. The relay passes the 230 V mains voltage to the four heating rods connected in series, providing 750 W. The other Eurotherm controller is used for overheat protection by disabling the power output if the thermocouple inside one of the heating rods reaches a set temperature limit. The Genlab Control Station communicates with the LabVIEW program on the pc via RS-485.

The thermal performance of the cell is tested, with the cell chamber being vacuum or filled with 100 mbar argon or 1 bar of air. In vacuum the aluminum sample support plate reaches a maximum temperature of 380°C when the heater rod temperature is limited to 550°C. This large difference is expected due to the limited contact between the heating rods and the steel plate in which the rods are inserted and because of the absence of a gas providing some of the heat transfer. The top surface of a 3 inch diameter, 5 mm thick quartz substrate reached a temperature of 310°C. This was measured using a third thermocouple pressed down on the surface with a lever.

As expected, operating the cell in argon or air yields much smaller temperature differences between the heating rods, aluminum sample support plate and the top of the 5 mm thick quartz substrate. When limiting the heating rods to 450° C, the temperature in the sample stage reaches 350° C in 100 mbar argon. It illustrates that instead of heating a sample in vacuum, some argon (or helium) gas can be used as exchange gas to improve the heat transfer from the heating rods to the sample. We are currently reviewing options to improve this thermal contact.

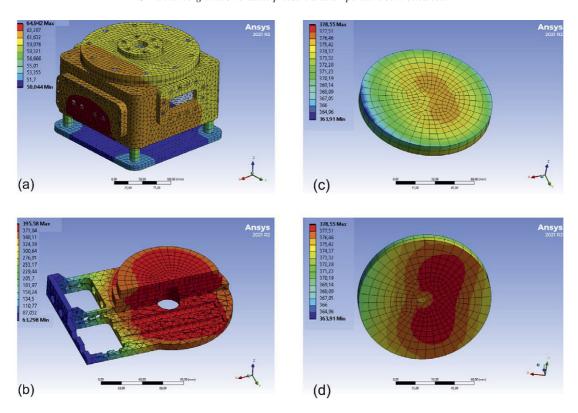


Fig. 7. Temperature distribution of the cell when the temperature of the heating rods is set to 400°C and the cell is pressurized with 10 bar of helium. (a) Entire cell body, (b) sample support and heating plate, (c) close-up of the sample in NR mode, (d) close-up of the sample in SANS mode. The black lines indicate the elements used for the finite element method simulations.

Table 4 Results of the thermal simulations when the temperature of the heating rods are set to 400° C and the cell is (i) under vacuum, (ii) filled with 10 bar Argon and (iii) filled with 10 bar He

	Vacuum	10 bar Argon	10 bar Helium
Heating rods temperature [°C]	400	400	400
Heat loss to environment (convection) [W]	33	45	120
Outer cell wall mean temperature [°C]	33	37	62
Outer cell wall max. temperature [°C]	36	40	65
Quartz window max. temperature [°C]	34	38	64
Sample temperature NR (surface, center) [°C]	390	388	374
Sample temperature SANS (surface, center) [°C]	389	388	376
Max. temperature gradient on sample surface for NR [°C]	3	3	4
Max. temperature gradient in sample for SANS [°C]	1	1	1

Above a sample plate temperature of 200°C, the cell body is water cooled with a brass cooling block attached to the side of the body to keep the body below 60°C. With water cooling, the maximum body temperature is 40°C with the heating rods at 550°C. This is measured with a surface temperature thermocouple on the body. The cooling block is built in-house with a 4 mm diameter channel using a flow rate of 1 l/min. A sample plate temperature of 200°C is reached within 6 minutes. The steady state temperature stability is within 1°C.

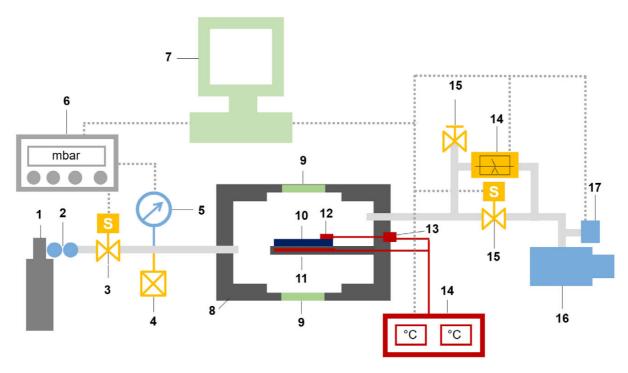


Fig. 8. Schematics of the pressure and temperature control system. In the schematics, the cell is positioned horizontally for neutron reflectometry measurements. (1) gas cylinder, (2) double-stage pressure regulator, (3) MKS instruments 0248AC-100SV solenoid inlet valve (n.c.), (4) pressure relief valve, (5) MKS instruments Baratron type 627DMCC1B manometer, (6) MKS instruments type 250E-1-D pressure controller, (7) personal computer, (8) pressure cell (0–10 bar), (9) single crystal quartz window, (10) sample, (11) heating plate with 4 60 V, 38 W heating rods connected in series, of which one has a thermocouple, (12) thermocouple clamped to the sample, (13) manual air-valve, (14) solenoid outlet valve, n.c. (Bronkhorst F-001AI-IIU033-V, connected to a Delta Elektronica ES030 – 5 power supply), (15) Bronkhorst F-201CV-200-AAD-33-V EL Flow Select 200 ml_n/min Ar n.c. mass flow controller, (16) Adixen Drytel 1025 vacuum pump, (17) Thyracont VSP64DL vacuum transducer.

2. Example of use: Hydrogenation of a Ta-based film

To illustrate the performance of the cell, we performed neutron reflectometry experiments on a Ta based thin film samples to determine the hydrogen concentration and expansion of the Ta layer when exposed to a certain partial hydrogen pressure. The samples consists of a 4 nm titanium adhesion layer, a 40 nm Ta sensing layer and a 10 nm $Pd_{0.6}Au_{0.4}$ capping layer (nominal thicknesses) to catalyze the hydrogen dissociation and recombination reaction and prevent the film from oxidation. The samples were produced by magnetron sputtering on quartz substrates with a diameter of 76.2 mm (3 inch) with a thickness of 3.0 mm, a surface roughness < 0.5 nm and a flatness of 2 lambda over 85% CA Central (Coresix Precision Glass, Inc., VA, USA) following a procedure described elsewhere [6].

The neutron reflectometry measurements were performed at the time-of-flight neutron reflectometer ROG located at the 2.3 MW HOR reactor of the Delft University of Technology, Delft, The Netherlands. The double disc chopper was set to a frequency of 17.7 Hz with an interdisc distance of 0.280 m resulting in a wavelength resolution of $\Delta\lambda$ $\lambda \approx 2.5\%$ and neutrons were detected using a 3 He detector. The incident angle was set to 8.5 mrad, the spectrum between 0.11 < λ < 1.0 nm leading to a Q-range of 0.11 < Q < 0.98 nm $^{-1}$. A first slit of 1.5 mm and a second slit 0.75 mm were used, of which the latter one was positioned approximately 150 mm from the sample, resulting in a footprint of $80 \times 40 \text{ mm}^2$ (umbra/penumbra) and a resolution of $\Delta Q/Q \approx 5\%$.

Figure 9 displays the room temperature neutron reflectometry results on the Ta-based thin film in air and under a partial hydrogen pressure of $P_{\rm H2} = 25$ kPa that is achieved by filling the cell with 6.1 bar of 4.0% of H₂ in 96% of Ar ($\Delta c_{\rm H2}/c_{\rm H2} < 2\%$, Linde Gas Benelux BV, Dieren, The Netherlands). The raw NR data show clear differences

Table 5

Specifications of the auxiliary equipment used for the pressure-, flow- and temperature control

Component	Model	Supplier
Inlet valve	MKS instruments 0248AC-10000SV solenoid inlet valve	MKS Instruments, Inc., Andover, Massachusetts, United States
Pressure controller	MKS instruments type 250E-1-D	MKS Instruments, Inc., Andover, Massachusetts, United States
Manometer	MKS Baratron type 627DMCC1B manometer	MKS Instruments, Inc., Andover, Massachusetts, United States
Outlet valve	Bronkhorst F-001AI-IIU033-V, connected to a Delta Elektronica ES030 – 5 power supply	Bronkhorst High-Tech BV, Ruurlo, The Netherlands
Flow controller	Bronkhorst F-201CV-200-AAD-33-V EL Flow Select 200 ml _n /min Ar n.c. mass flow controller	Bronkhorst High-Tech BV, Ruurlo, The Netherlands
Pump	Adixen Drytel 1025 vacuum pump	Pfeiffer Vacuum GmbH, Asslar, Germany
Vacuum transducer	Thyracont VSP64DL vacuum transducer	Thryracont Vacuum Instruments GmbH, Passau, Germany
DAQ	USB-6008 Low-Cost Multifunction I/O	National Instruments corp., Austin, Texas, United States
Thermocouple on sample	Type K thermocouple	Genlab Ltd., Cheshire, United Kingdom
Heating rods (4×)	Watlow type 2285-7052, 60 V, 200 W cartridge heaters, diameter 0.371 inch (9.4 mm), length 7.1 inch (180 mm) with built in K-type thermocouple.	Kurval B.V., Nieuw Vennep, The Netherlands
Temperature controller	Genlab Bench Top Control Station BTC2000/485	Genlab Ltd., Cheshire, United Kingdom

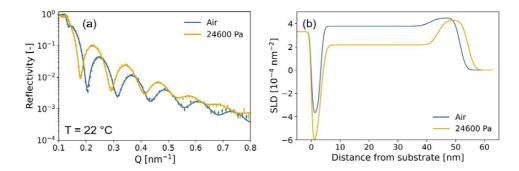


Fig. 9. In-situ NR results of the 40 nm Ta thin films with a 4 nm Ti adhesion layer and capped with a 10 nm $Pd_{0.6}Au_{0.35}Cu_{0.05}$ at $T=22^{\circ}C$ in air (no hydrogen) and at $P_{H2}=25$ kPa. (a) Reflectograms of the Ta thin film measured. The continuous lines represent fits of a model to the data on the basis of which estimates for the scattering length density and layer thickness are obtained. (b) Scattering length density (SLD) profiles.

in both the periodicity and the amplitude of the fringes, indicating a distinct change of the sample upon exposure to a hydrogen. To quantify these changes, we have fitted the data with GenX3 [10] to obtain estimates for the layer thickness, roughness and scattering length density (SLD). This yields a layer thickness expansion of 7.8%. Based on the expansion and the fitted SLDs of the Ta layers, we can estimate the hydrogen concentration in the Ta layer as:

$$x = \left(\frac{SLD_{\text{TaH}_x}}{SLD_{\text{TaH}_x}} \frac{d_{\text{TaH}_x}}{d_{\text{Ta}}} - 1\right) \frac{b_{\text{Ta}}}{b_{\text{H}}},\tag{2}$$

with $SLD = \sum_{i=1}^{N} b_i N_i$ the SLD of the layer, $b_{Ta} = 6.91$ fm and $b_{H} = -3.739$ fm the scattering lengths of

tantalum and hydrogen, respectively [25], and N_i the number of atoms i per volume unit [9]. Substituting the values resulted in a hydrogen content of x = 0.73 at $P_{\rm H2} = 25$ kPa and T = 22°C.

Besides the example above, we have already used the hydrogenation cell for several studies, of which some have been published [1,8,22].

3. Conclusion

In conclusion, we have successfully designed and realized a cell of which the temperature and pressure can be controlled and that can be used in combination with NR and SANS. The cell is compatible with simultaneous optical transmission and resistivity measurements, can accommodate samples up to 4 inch in diameter, be pressurized up to 10 bar, and temperature controlled up to 350°C while also allowing operation in vacuum. The four single crystal quartz windows ensure a high neutron and optical transmission. The performances of the cell is illustrated with neutron reflectometry experiments performed on a Ta based thin films under a hydrogen-containing atmosphere. The cell and engineering drawings thereof are available to the user community upon reasonable request.

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